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Electronic Patent Application Submission
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EFS ID: 21797
Application ID: 10065861
Title of Invention: DRYING PROCESS FOR LOW-K
DIELECTRIC FILMS
First Named Inventor: Carlo Waldfried
Domestic/Foreign Application: Domestic Application
Filing Date: 2002-11-26
Effective Receipt Date: 2003-01-14
Submission Type: Information Disclosure Statement
Filing Type: null
Confirmation Number: 3384
Attorney Docket Number: ATI-0016
Digital Certificate Holder: cn=Peter Robert Hagerty, ou=Registered Attorneys, ou=Patent and
Trademark Office, ou=Department of Commerce, o=U.S.
Government, c=US
Certificate Message Digest: 3ML0LeOMS9WyCz5kn6Mb1A==



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Stylesheet Version: 1.0

Submission Type: Information
Disclosure Statement

Application Number: 10/065861
Attorney Docket Number: ATI-0016

DRYING PROCESS FOR LOW-K DIELECTRIC FILMS

First Named Inventor: Mr. Carlo Waldfried

SUBMITTED BY

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Comments:

Electronic Information Disclosure Statement



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Application: 
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Applicant(s): Carlo Waldfried

Docket
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search string: (4341592 or 4885047 or 5498308 or 6203582 or 6235453 or 6238161 or 6281135 or 6328809 or 20010010950 or 20010048867 or 20010030101 or 20010051082 or 20020033136 or 20010037822 or 20020037655).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	P01	4341592	1982-07-27		Shortes, et al.		
	P02	4885047	1989-12-05		Ury, et al.		
	P03	5498308	1996-03-12		Kamarehi, et al.		
	P04	6203582	2001-03-20		Berner, et al.		
	P05	6235453	2001-05-22		You, et al.		
	P06	6238161	2001-05-29		Kirkpatrick, et al.		

	P07	6281135	2001-08-28		Han, et al.
	P08	6328809	2001-12-11		Elsawy, et al.

Published Applications

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Citation No.	Patent Number	Date	Bar Code	Patentee	Class	Subclass
	U01	20010010950	2001-08-02		Savage, et al.		
	U02	20010048867	2001-12-06		Lebar, et al.		
	U03	20010030101	2001-10-18		Berner, et al.		
	U04	20010051082	2001-12-13		Kirkpatrick, et al.		
	U05	20020033136	2002-03-21		Savage, et al.		
	U06	20010037822	2001-11-08		Elsawy, et al.		
	U07	20020037655	2002-03-28		Hasunuma, et al.		

Signature

Examiner Name	Date